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**GROUP 1700**

Date: June 9, 2003

**TO:** Examiner Steven H. Versteeg (703) 872-9311  
Art Unit: 1753

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Subject Matter: 09/ 976,082 Attorney Doc: 67,200-530

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## GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chung-En Kao

Group Art Unit: 1753

Serial No.: 09/976,082

Examiner: Steven H. Versteeg

Filed: Oct. 12, 2001

In Response to Office Action  
Dated: April 7, 2003

For: Apparatus And Method For Self-Centering A Wafer  
In A Sputter Chamber

Attorney Docket No.: 67,200-530

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(N.E)  
W.M.  
7/11/03

### Certificate of Facsimile

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Kathy Dixon

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July 14, 2003

### REQUEST FOR RECONSIDERATION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to a final Office Action mailed April 7, 2003, please enter the following amendments and consider the following remarks.